

Form PTO-1449
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Att'y Docket No.

9911.1 Kelly

Serial No.

09/

Applicant:

Kevin W. Kelly *et al*

Filing Date

October 25, 2001

Group Art Unit:

3743

**INFORMATION DISCLOSURE CITATION**

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U.S. PATENT DOCUMENTS

Exam. Initial	Document No.	Date	Name	Class	Subcl.	File Date

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CERTIFICATE

I hereby certify that this Information Disclosure Citation and copies of the three cited references are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Box Non-Fee Amendment, Washington, D.C. 20231 on January 4, 2002.

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